



Sheet 1 of 1

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE	ATTY DOCKET NO. 110157.99	APPLICATION NO. 08/994,758	
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)		APPLICANT Kenji NISHI			
		FILING DATE December 19, 1997	GROUP 2851		
U.S. PATENT DOCUMENTS					
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS
AM		5,506,684	4/1996	OTA et al.	—
FOREIGN PATENT DOCUMENTS					
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS
AM		JP A-4-196513 (w/abstract)	7-1992	Japan	—
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)					
AM		Buckley et al., "Step and scan: A systems overview of a new lithography tool", SPIE Vol. 1088 Optical/Laser Microlithography II (1989), p. 424-433.			
EXAMINER	Alan Mathews			DATE CONSIDERED 12-7-2001	
Examiner:	Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.				